

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date April 28, 2011

In re the Application of

Toru YAMADA

Application No.: 10/582,802

Filed: June 14, 2006

For: VAPOR PHASE GROWTH APPARATUS AND METHOD OF FABRICATING EPITAXIAL
WAFER



Group Art Unit: 1714

Examiner: M. SONG

Docket No.: 136170

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired April 24, 2011, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 237088 in the amount of \$130.00 in payment for:

X Extension fee for response within first month pursuant to §1.136(a) (\$130.00)
_____ Extension fee for response within second month pursuant to §1.136(a) (\$490.00)
_____ Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1,110.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated for this filing to Deposit Account No. 15-0461.

Respectfully submitted,

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WPB:AQS/sxl

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**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry of this filing;
Charge any fee due to our
Deposit Account No. 15-0461